



ITW

<b>AMENDMENT TRANSMITTAL LETTER</b>				Docket No. ISH-0234	
Application No. 10/543,166-Conf. #7946		Filing Date July 22, 2005		Examiner A. Aboulfaida	
				Art Unit 2891	
Applicant(s): Hideki YAMANAKA et al.					
Invention: SILICON SEMICONDUCTOR SUBSTRATE AND METHOD FOR MANUFACTURING THE SAME					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
<b>Total Claims</b>	18	- 20 =	0	x 50.00	0.00
<b>Independent Claims</b>	2	- 3 =	0	x 210.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					0.00
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00
<input checked="" type="checkbox"/> Large Entity <span style="margin-left: 200px;"><input type="checkbox"/> Small Entity</span>					
<input type="checkbox"/> No additional fee is required for this amendment.					
<input checked="" type="checkbox"/> Please charge Deposit Account No. <u>18-0013</u> in the amount of \$ _____ A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>18-0013</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Carl Schaukowitz Attorney/Agent Reg. No.: 29,211				Dated: <u>January 2, 2008</u>	
RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750					



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Patent Application of:  
Hideki Yamanaka et al.

Attorney Docket No. ISH-0234

Application No.: 10/543,166

Confirmation No.: 7946

Filed: July 22, 2005

Art Unit: 2891

Examiner: A. Aboulfaida

For: SILICON SEMICONDUCTOR  
SUBSTRATE AND METHOD FOR  
MANUFACTURING THE SAME

**AMENDMENT UNDER 37 C.F.R. §1.111**

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**I. INTRODUCTORY COMMENTS**

In response to the Office Action dated October 5, 2007, please amend the above-identified application as set forth below.

Claims 1-11 are pending in the application. By this Amendment, claims 1 and 4-6 are amended and claim 11 is added.

**II. AMENDMENTS TO THE DRAWINGS**

(There are no amendments to the drawings)

**III. AMENDMENTS TO THE SPECIFICATION**

(There are no amendments to the specification)